

Refine Search

Search Results -

Terms	Documents
semiconductor and (trench or groove) and pad and mask and etch	4

Database:

US Pre-Grant Publication Full-Text Database
 US Patents Full-Text Database
 US OCR Full-Text Database
 EPO Abstracts Database
JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L6

Search History

DATE: Wednesday, July 14, 2004 [Printable Copy](#) [Create Case](#)

Set Name Query

side by side

Hit Count Set Name

result set

DB=JPAB; PLUR=YES; OP=ADJ

L6 semiconductor and (trench or groove) and pad and mask and etch

4 L6

DB=EPAB; PLUR=YES; OP=ADJ

L5 semiconductor and (trench or groove) and pad and mask and etch

2 L5

DB=USPT; PLUR=YES; OP=ADJ

L4 semiconductor and (trench or groove) and pad and mask and etch

4420 L4

DB=PGPB; PLUR=YES; OP=ADJ

L3 semiconductor and (trench or groove) and pad and mask and etch

1907 L3

DB=TDBD; PLUR=YES; OP=ADJ

L2 semiconductor and (trench or groove) and pad and mask and etch

6 L2

DB=DWPI; PLUR=YES; OP=ADJ

L1 semiconductor and (trench or groove) and pad and mask and etch

204 L1

END OF SEARCH HISTORY